

**DECLARATION AND POWER OF ATTORNEY**

(Docket No. 207.005-US)

As a below-named inventor, I hereby declare that:

My residence, mailing address, and citizenship are as stated below next to my name.

I believe I am an original, first and joint inventor of the inventions described and claimed in the specification attached hereto and entitled:

**CRACK AND RESIDUE FREE CONFORMAL DEPOSITED SILICON OXIDE WITH  
PREDICTABLE AND UNIFORM ETCHING CHARACTERISTICS**

I hereby state that I have reviewed and understand the contents of the above-identified specification, including the claims, as amended by any amendment specifically referred to herein.

I acknowledge the duty to disclose information that is material to the examination of this application in accordance with 37 CFR § 1.56.

I hereby appoint Neil Steinberg, Reg. No. 34,735, and Stephen Whitt, Reg. No. 34,753, with full power of substitution and revocation, to prosecute this application and transact all business in the U.S. Patent and Trademark Office connected therewith. The current mailing address and telephone and facsimile numbers are:

Neil Steinberg  
Steinberg & Whitt, LLP  
2665 Marine Way, Suite 1150  
Mountain View, California 94043

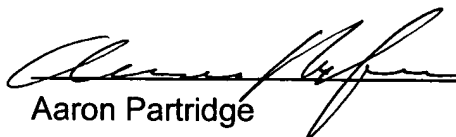
Tel: 650-968-8079  
Fax: 650-968-8102

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of

the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issued thereon.

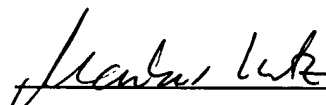
First Inventor: Aaron Partridge  
Residence: 224 N. California Ave., Palo Alto, CA 94301  
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Date: 10/28/2003

  
Aaron Partridge

Second Inventor: Markus Lutz  
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Mailing Address: 4214 Manuela Ave., Palo Alto, California 94306

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Markus Lutz

Third Inventor: Silvia Kronmueller  
Residence: Ludwigsburger Str 57, 71409 Schwaikheim, Germany  
Citizenship: Germany  
Mailing Address: Ludwigsburger Str 57, 71409 Schwaikheim, Germany

Date: \_\_\_\_\_

\_\_\_\_\_  
Silvia Kronmueller

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Date: 12 Nov 03

  
\_\_\_\_\_  
Silvia Kronmueller